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NO. 7723—P. 1

PTO/SB/97 (08-03)

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Raquel Garcia

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Application Number See attached Schedule A

Filing Date See attached Schedule A

In re of Applicant: Tokyo Ohka Kogyo Co., Ltd.

Art Unit unassigned

Examiner Name unassigned

Attorney Docket Number See attached Schedule A

Note: Each paper must have its own certificate of transmission, or this certificate  
must identify each submitted paper.

Change of Correspondence Address with attached Schedule A (3 pages)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re of Applicant: Tokyo Ohka Kogyo Co., Ltd. Docket No.: See attached Schedule A  
Serial No.: See attached Schedule A Art Unit: Not yet designated  
Filing Date: See attached Schedule A Examiner: Not yet designated

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313

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**CHANGE OF CORRESPONDENCE ADDRESSES**

Applicants respectfully requests the Examiner to change the correspondence address for the following applications as listed in the attached Schedule A to the address associated with the attorney of record:

Customer No.:	38,552		
Individual Name:	John W. Ryan		
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If necessary, please charge any fees in connection with this submission or credit any overpayments to our Deposit Account No. 50-2787. If you have any questions regarding this submission, please contact the undersigned attorney at the local Washington DC office.

Respectfully submitted,

  
John W. Ryan  
Registration No. 33,771

Date: December 7, 2004

DECHERT, LLP  
1775 I Street, N.W.  
Washington, DC 20006

**Schedule A**

**Change of Correspondence Address**  
**Client: Tokyo Ohka Kogyo Co., Ltd**  
**Customer Number: 38,552**

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NO. 7723

**Attorney Docket: 372106-101**

**Title:** Resist Developer and Resist Pattern Formation Method Using Same  
**Client:** Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/422,548	24-Apr-2003

**Attorney Docket: 372106-102**

**Title:** SILICA-BASED ORGANIC FILM AND METHOD OF  
MANUFACTURING THE SAME, AND BASH MATERIAL  
COMPRISING ORGANIC FILM  
**Client:** Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/616,731	10-Jul-2003
US	10/800,822	15-Mar-2004

DECHERT LLP

**Attorney Docket: 372106-103**

**Title:** POSITIVE TYPE RESIST COMPOSITION AND RESIST  
PATTERN FORMATION METHOD  
**Client:** Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/466,172	14-Jul-2003

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Schedule A

Change of Correspondence Address  
Client: Tokyo Ohka Kogyo Co., Ltd  
Customer Number: 38,552

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NO. 7723

Attorney Docket: 372106-104

Title: POSITIVE TYPE RESIST COMPOSITION AND RESIST  
PATTERN FORMATION METHOD  
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/466,473	14-Jul-2003

Attorney Docket: 372106-105

Title: PHOTORESIST PATTERN AND FORMING METHOD THEROP  
Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/628,919	29-Jul-2003

Attorney Docket: 372106-106

Title: Positive Type Resist Composition and Resist Pattern Formation  
Method Using Same  
Client: Tokyo Ohka Kogyo Co., Ltd.

DECHERT LLP

Country	Application Number	Filing Date
US	10/467,130	01-Aug-2003

Attorney Docket: 372106-107

Title: BASE MATERIAL FOR LITHOGRAPHY  
Client: Tokyo Ohka Kogyo Co., Ltd.

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Country	Application Number	Filing Date
US	10/648,762	26-Aug-2003

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**Schedule A**  
**Change of Correspondence Address**  
**Client: Tokyo Ohka Kogyo Co., Ltd**  
**Customer Number: 38,552**

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NO. 7723

**Attorney Docket: 372106-108**

**Title:** Preparation for Nano Material, Metal Oxide Nano Material Formation  
Composition Used for the Method, Mold and Metal Oxide Nano  
Structure

**Client:** Tokyo Ohka Kogyo Co., Ltd.

<b>Country</b>	<b>Application Number</b>	<b>Filing Date</b>
US	10/840,192	06-May-2004

**Attorney Docket: 372106-109**

**Title:** Resist Composition  
**Client:** Tokyo Ohka Kogyo Co., Ltd.

<b>Country</b>	<b>Application Number</b>	<b>Filing Date</b>
US	10/845,620	13-May-2004

**Attorney Docket: 372106-110**

**Title:** Positive Resist Composition and Formation Method of Resist Pattern  
**Client:** Tokyo Ohka Kogyo Co., Ltd.

<b>Country</b>	<b>Application Number</b>	<b>Filing Date</b>
US	10/859,904	03-Jun-2004

**Attorney Docket: 372106-111**

**Title:** Positive Resist Composition and Resist Pattern Forming Method  
**Client:** Tokyo Ohka Kogyo Co., Ltd.

<b>Country</b>	<b>Application Number</b>	<b>Filing Date</b>
US	10/865,040	10-Jun-2004

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